



Steven M. Rabin  
Robert H. Berdo, Jr.  
Phillip G. Avruch  
Allen Wood  
Qixia Zhang, Pat. Agent (China)

**RABIN & BERDO, P.C.**  
*Specializing in Patent, Trademark  
And Copyright Law*

Suite 500, 1101 14<sup>th</sup> Street, N.W.  
Washington, D.C. 20005  
Tel.: (202) 371-8976 Fax: (202) 408-0924  
E-Mail: firm@rabinchamp.com

*In Affiliation with*  
Weiss, Moy & Harris, PC  
having offices in Arizona and Nevada,  
and in Washington, DC with  
Rabin & Berdo, PC



November 28, 2003

**Mail Stop Patent Application**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attorney Reference: **OHG 147**

**Re:** New Patent Application of: Makoto TERUI  
**Title:** SEMICONDUCTOR DEVICE

Sir:

Please find attached hereto an application for patent that includes:

- [x] Specification, Claims and Abstract (38 Pages)
- [x] 20 Sheets of Formal Drawings (Figs. 1 to 20)
- [x] Claim for priority (one priority document to be submitted later).

The right of priority is claimed under 35 USC §119 of Japanese Application No. JP 346256/2002 filed November 28, 2002 (document to be submitted later).

Respectfully submitted,

November 28, 2003

Date

Steven M. Rabin (Reg. No. 29,102)  
Customer No. 23995

SMR:pjl